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Attorney for Applicant

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.

10/642,929

Confirmation No.: 3856

Applicant

. . . . . .

Kenji Sakai et al.

POLISHING METHOD AND POLISHING

Title

COMPOSITION USED FOR POLISHING

Filed

August 18, 2003

TC/A.U.

1763

Examiner

George A. Goudreau

Docket No.

2281.2.15 21552

Customer No. :

Mail Stop Amendment Commissioner for Patents

P.O. Box 1450 Alexandria, VA 22313-1450

## RESPONSE TO RESTRICTION REQUIREMENT

Dear Sir:

This paper is submitted in response to the Election/Restriction Requirement mailed January 5, 2005. Applicants elect the invention of Group I, claims 1-10. If the Examiner requires any further information he is requested to contact the undersigned.

Respectfully submitted,

Evan R. Witt

Reg. No. 32,512 Attorney for Applicants

Date: January 18, 2005

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